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Joseph F. Hetz - Reg. No. 41,070

Name of Applicant, Assignee or  
Registered Representative

[Signature]  
Signature

Our Case No. 10519-57

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
Herner et al. )  
Serial No.: 09/928,975 )  
Filed: August 13, 2001 )  
For: Low Resistivity Titanium Silicide )  
on Heavily Doped Semiconductor )

Examiner: T. Magee

Group Art Unit: 2811

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**AMENDMENT AND RECORD OF INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please enter the following amendment and remarks in response to the Office Action mailed January 6, 2003.

**IN THE CLAIMS**

Please amend Claim 8 as follows. Appendix A (at Tab A) contains a marked-up version of this claim showing the changes being made.